H'A

Notice of Allowability	Application No.	Applicant(s)
	10/538,476	REYNET ET AL.
	Examiner	Art Unit
	Shih-Chao Chen	2821
The MAILING DATE of this communication apper All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI	(OR REMAINS) CLOSED in this app or other appropriate communication GHTS. This application is subject to	plication. If not included will be mailed in due course. THIS
1. This communication is responsive to the application filed on	<u>n June 7, 2005</u> .	
2. The allowed claim(s) is/are 24-46.		
3.	been received. been received in Application No cuments have been received in this application. Itted. Note the attached EXAMINER's reason(s) why the oath or declarate the submitted. It be submitted. It is application. It is application to file a reply of this application.	complying with the requirements S AMENDMENT or NOTICE OF tion is deficient. 948) attached ffice action of the back) of the submitted. Note the
 Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/05 Paper No./Mail Date 9/7/05 (Jun 7-05) 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material 	6. ☐ Interview Summary (Paper No./Mail Date 8), 7. ☐ Examiner's Amendm	e

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DETAILED ACTION

Allowable Subject Matter

- 1. Claims 24-46 are allowed (Claims 1-23 are canceled by Applicant).
- 2. The following is an examiner's statement of reasons for allowance:

The primary reason for the allowance of claims 24-46 is the inclusion of the limitation of conductor patterns mechanically linked to the substrate, wherein at least some of the conductor patterns mechanically linked to the substrate are associated with a magnetic tile placed on or above one of the first and second faces of the substrate, and at least one electrical interconnection puts two points in electrical contact distinct from one another of one of the conductor patterns mechanically linked to the substrate. It is this limitation found in each of the claims, as it is claimed in the combination, that has not been found, taught or suggested by the prior art of record which makes these claims allowable over the prior art.

McKinzie, III et al. (US 2005/0030137 A1) teaches a magnetically-loaded artificial magnetic conductor surface provides enhanced bandwidth. The structure includes in one embodiment a thumbtack structure with a spacer layer that is loaded with a barium-cobalt hexaferrite based artificial magnetic material. Specifically, the geometry consists of a ground plane covered with thinly sliced ferrite tiles that are metallized and stacked. Each tile has a metal via running through its center that is electrically connected to the plated metalized surfaces. However, McKinzie does not disclose or suggest conductor patterns mechanically linked to the substrate, wherein at least some of the conductor patterns mechanically linked to the substrate are

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associated with a magnetic tile placed on or above one of the first and second faces of the substrate, and at least one electrical interconnection puts two points in electrical contact distinct from one another of one of the conductor patterns mechanically linked to the substrate.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Correspondence

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Shih-Chao Chen whose telephone number is (571) 272-1819. The examiner can normally be reached on Monday-Friday from 7 AM to 4:30 PM, First Fri. off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Don Wong can be reached on (571) 272-1834. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Shih-Chao Chen Primary Examiner Art Unit 2821

BHIH-CHAO CHEN PRIMARY EXAMINER

SXC March 1, 2006